



Data analytics framework for advanced manufacturing

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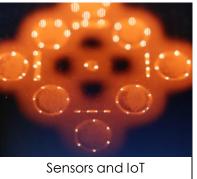
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Digital platform for qualification and certification of advanced manufacturing processes



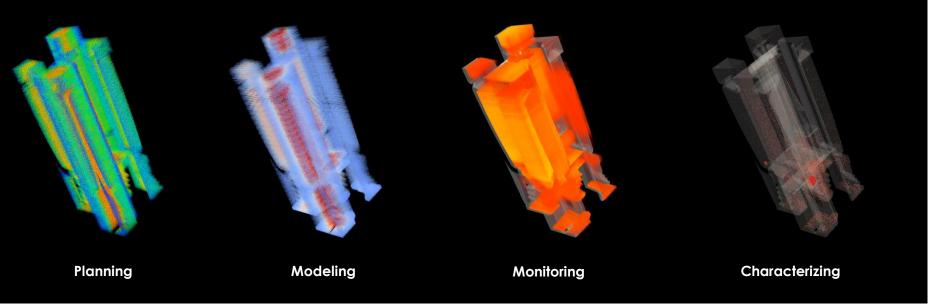










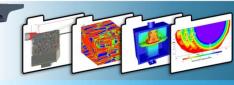


Driving the Next Materials Revolution

Creating a Framework for Coupling Data Analytics with Advanced Manufacturing







Modeling



Intent



In-Situ



Ex-situ & Properties



DREAM.3D

Open Source Edition

Data Management & Tracking

Signal Processing

Computer Vision & Image Processing

n-D Data Visualization

Modeling & Simulation

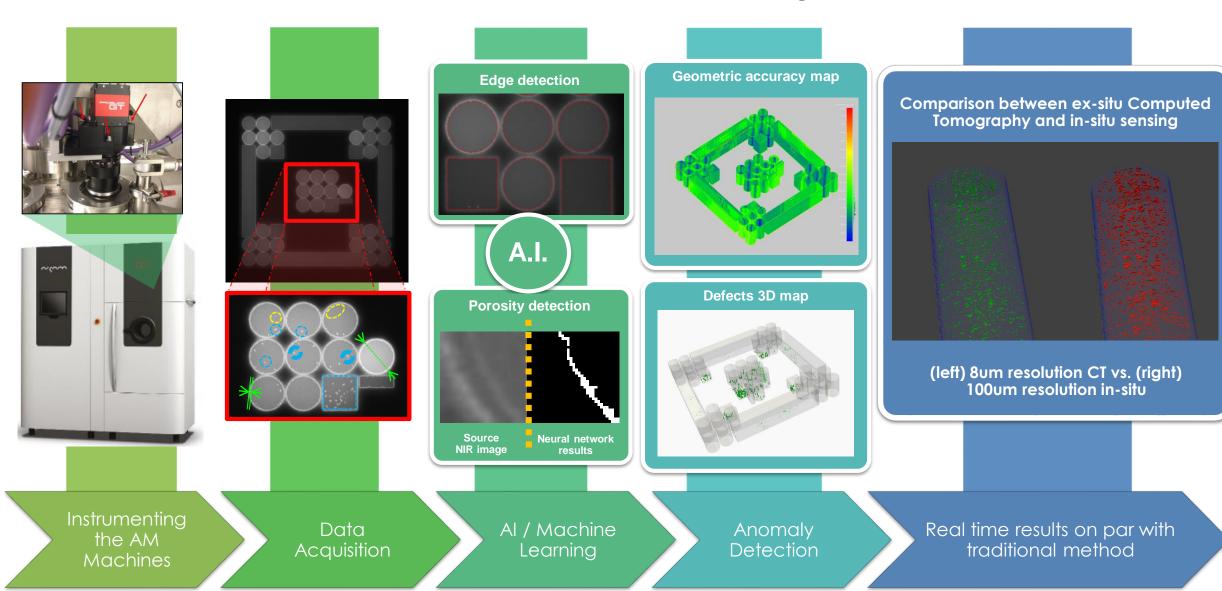
Data Analytics & Machine Learning

Process Optimization

Certification, Verification & Validation

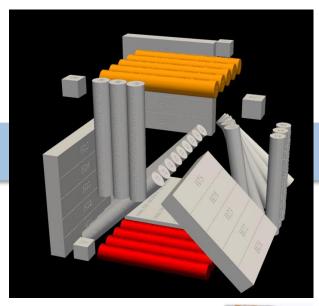


In-Situ Quality Control of AM Processes using Al

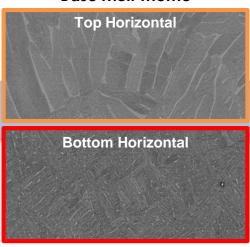


Achieving Uniform, Defect-Free Microstructures through

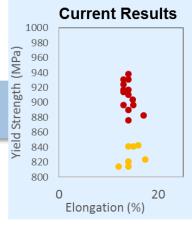
Data Analytics and Al



Micrographs Base Melt Theme



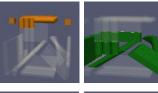
Scattered mechanical testing results



820

800

Elongation (%)

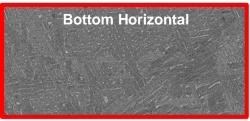




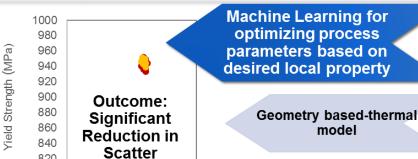


Geometry with varying cross section and printing time per layer



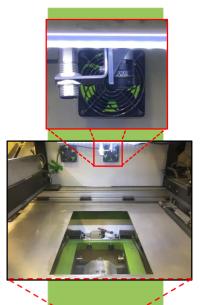


Micrographs Modified Melt Theme



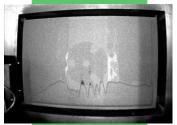
Link Microstructure and Defects to Key Process Parameters

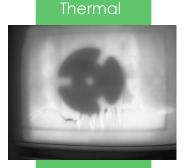
BinderJet: AI based defect detection and correction

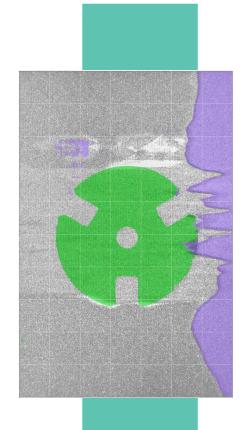


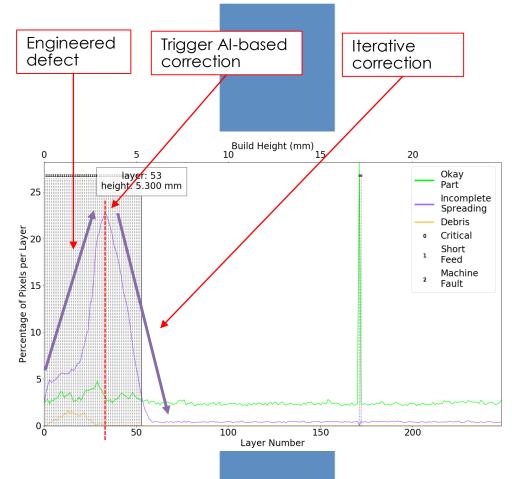












ExOne M-Flex equipped with in-situ sensing

In-situ imaging modalities: visible and infrared

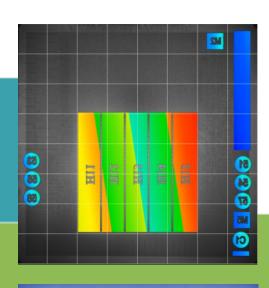
Al-based defect detection

Implementation of an Al-based feedback loop control for defect correction



Scan strategy optimization for microstructure control

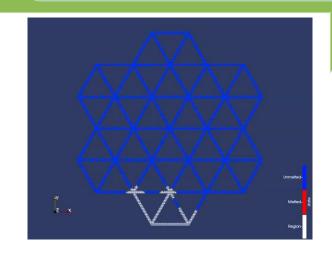
Understand limitations of current scan strategies

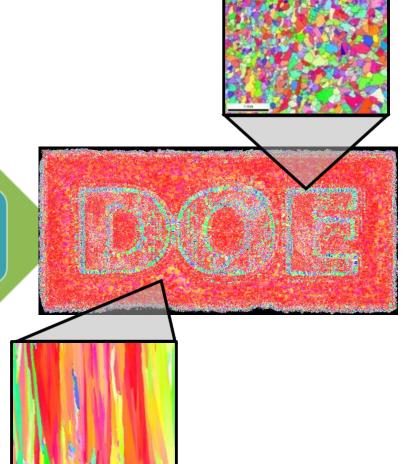






Optimize scan strategies to control thermal gradients









Questions?

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